

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori et al.

Serial No. : 10/623,581

Filed : July 22, 2003

Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM
TRANSISTOR

Art Unit : 2811

Examiner : Stanetta Isaac

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form.

Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

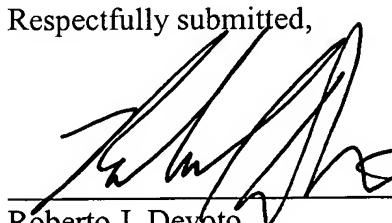
This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Date:

12/5/05

Fish & Richardson P.C.
1425 K Street, N.W.
11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

Respectfully submitted,



Roberto J. Devoto
Reg. No. 55,108



Sheet 1 of 1

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024003	Application No. 10623,581
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Isamu Kobori et al.		
		Filing Date July 22, 2003	Group Art Unit 2811	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,670,297	09/23/1997	Ogawa et al.			11/09/1995
	AB	2004/0227184	11/18/2004	Kobori et al.			11/17/2003
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AL						
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	